L	Hits	Search Text	DB	Time stamp
Number			•	
1	37	wafer AND ((oxygen NEAR5 concentration)	USPAT;	2004/10/19
		NEAR15 threshold)	US-PGPUB;	13:19
ļ			EPO; JPO;	
			DERWENT	
-	187	(oxygen NEAR3 concentration) NEAR10	USPAT;	2004/10/18
		(oxide NEAR7 thickness)	US-PGPUB;	10:24
			EPO; JPO;	İ
			DERWENT	
-	59	(oxygen NEAR3 concentration) NEAR10	USPAT;	2004/10/18
		(oxide NEAR7 thickness) AND leak\$5	US-PGPUB;	17:13
			EPO; JPO;	
			DERWENT	
-	11	(oxygen NEAR3 concentration) NEAR10	USPAT;	2004/10/18
		(wafer NEAR7 thickness) AND leak\$5	US-PGPUB;	17:14
			EPO; JPO;	
			DERWENT	
-	5201	,	USPAT;	2004/10/18
		AND leak\$5	US-PGPUB;	17:21
			EPO; JPO;	
			DERWENT	
-	71	,	USPAT;	2004/10/18
		SAME (oxygen NEAR3 concentration) AND	US-PGPUB;	17:22
		leak\$5	EPO; JPO;	
			DERWENT	